IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: FUJII et a

Application No.: 09/749,693

Filed: December 28, 2000

Title: SEMICONDUCTOR MECHANICAL

SENSOR

Allowed: September 13, 2001

Batch No.: L96

Group: 2856

Examiner: H. Kwok

October 9, 2001

## INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents Washington, D. C. 20231

Sir:

Attached is a Form PTO-1449 listing the enclosed documents.

The attached documents have been cited in a corresponding foreign Official Action. Please also see the attached sheet for additional comments regarding the relevance. The foreign Official Action was mailed August 7, 2001, which is less than three months from the date of this Information Disclosure Statement.

This Information Disclosure Statement is intended to be in full compliance with the rules, but should the Examiner find any part of its required content to have been omitted, prompt notice to that effect is earnestly solicited, along with additional time under Rule 97(f), to enable Applicant to comply fully.

Since a Notice of Allowance has been issued before the filing date of this Information Disclosure Statement, please consider this a Petition under Rule 97(d)(ii), charge the petition fee to our Deposit Account No. 03-3975 under Order No. 11349/275339, and proceed to consider this information Disclosure Statement under Rule 97(d).

Consideration of the foregoing and enclosures plus the return of a copy of the herewith Form PTO-1449 with the Examiner's initials in the left column per MPEP 609 are earnestly solicited.

Respectfully submitted,

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